Arc Appearance and Cathode Spot Distribution in a Long-Gap High-Current Vacuum Arc Controlled by an External Axial Magnetic Field

B. Tezenas du Montcel, P. Chapelle, C. Creusot, and A. Jardy

Abstract—An experimental study of a high-current vacuum arc generated between two static CuCr25 contacts spaced 20 or 30 mm apart was conducted to characterize the arc appearance and the cathode spot (CS) distribution. The arc was ignited from the lateral surface of the cathode and controlled using an external axial magnetic field. Under the investigated experimental conditions, three distinct arc modes have been observed: multiple arc, diffuse, and diffuse columnar modes. The latter appeared at low B_{AMF}/I_{arc} values, typically below 4 mT/ka. The temporal evolutions of the spot spatial distribution and the associated distribution of the current density were analyzed by processing high-speed video images of the cathode. Various types of distribution depending mainly on current were identified. At low currents (up to 13 ka), the CS distribution covered only a fraction of the cathode surface. At intermediate currents (in 17.2–31.1-ka range), CSs were present on the whole circumference of the cathode and the CS distribution included a closed region without spot. The latter was progressively filled by CSs, yet it totally disappeared before the end of arcing only when its location was offset-centered with respect to the cathode axis. At high currents (up to 36.3 ka), the whole cathode surface was occupied by CSs at current peak. The azimuthally averaged radial distribution of the current density was found to be relatively uniform in the regions occupied by CSs. An average spot current of 36.5 ± 2.5 A has been estimated.

Index Terms—Arc appearance, axial magnetic field (AMF), cathode spot (CS) distribution, experimental study, long gap, vacuum arc (VA).

I. INTRODUCTION

VAcuum interrupter is nowadays the most widely used switching technology for medium-voltage applications, whereas an SF6 interrupter is the dominant technology in high-voltage applications. In an attempt to develop SF6-free alternative circuit breakers owing to environmental considerations, research efforts are currently being made to increase the voltage rating of vacuum interrupters [1], [2]. As a result, the behavior of a vacuum arc (VA) for a contact gap above 10 mm needs to be better understood. Studies on this latter point are still limited. Most of the published papers on this topic are focused on VAs controlled with an axial magnetic field (AMF). Studies have been carried out for the case of large (10–40 mm) and very large (40–60 mm) contact gaps. Cheng et al. [3] investigated the VAs with current up to 14.25 ka between 50-mm-diameter electrodes spaced 40 mm apart. Instable arc modes for the highest currents were mentioned for this configuration. Xiu et al. [4] have studied into more detail about these instabilities for the VAs with current up to 11 ka for 75–100-mm-diameter electrodes with gaps in 20–60-mm range. They classified them into two groups (normal and spiral distortions) and correlated their apparition with a magnetohydrodynamic criterion. Recently, Wang et al. [5] have studied the increase of the plasma constriction near the anode, within a 10–40-mm contact gap range, for applied current up to 28 ka and using either 90-mm-diameter cup-shaped electrodes or 110-mm-diameter coil-type electrodes. Besides the behavior of the interelectrode plasma, the appearance of the VAs at the anode has also been investigated by a few researchers. Cheng and Wang [6] have analyzed the anode phenomena for the VAs with very large gaps for 100-mm-diameter single-coil-type electrodes. Considering drawn arcs between 100-mm-diameter 2/3-coil-type electrodes, Yao et al. [7] have investigated, for the large and very large gaps, the various modes of existence of the arc at the anode (passive anode, footprint, and anode spot) according to the current and arc length.

In the VA, the plasma is emitted at the cathode surface by tiny, mobile cathode spots (CSs). Their motion and spatial distribution have a significant influence on the arc aspect and the plasma parameters [8]. CS motion is influenced by numerous factors, such as surface conditions, magnetic field intensity, and plasma density [9], [10]. To determine the spatial distribution of CSs over the cathode surface, Afanas’ev et al. [11] developed an original processing method based on the posttreatment of cathode images (previously) recorded with
a high-speed camera. In this method, the position of the CSs is extracted by filtering light intensity contours. Moreover, the method allows estimating the distribution of the current density at the cathode from the reconstructed CS distribution. Up to now, the method was employed to investigate the VAs with small gap spacing (from 2 to 16 mm) with a current of 3–25 kA and the contacts of 30–50-mm diameter [10], [12]–[14]. Moreover, it should be noted that all of these studies were performed for static contacts, the arc triggering being carried out with an auxiliary electrode placed at the cathode center.

This paper aims to investigate experimentally the behavior of AMF-controlled VAs with a large-gap distance (20 or 30 mm) triggered with an auxiliary electrode placed close to the cathode outer diameter. First, arc visualization results are presented, describing arc mode and the interelectrode plasma appearance. Then, the temporal evolutions of the CS distribution and the current density are described, applying a similar spot detection method as proposed by Afanas’ev et al. [11].

II. EXPERIMENT

A. Setup

Experiments have been conducted in a demountable vacuum chamber with a pumping system capable of maintaining a vacuum ranging from $10^{-7}$ to $10^{-5}$ Pa, as shown in Fig. 1. A pair of static electrodes was disposed inside the chamber with a controlled gap. The contacts were 70-mm-diameter hollow cylinders of oxygen free high thermal conductivity copper, surmounted by 2-mm-thick CuCr25 alloy disks. A 16-turns Helmholtz coil pair was installed outside the chamber to generate an AMF in the contact gap region. The arc was triggered with the help of an auxiliary electrode located close to the cathode outer diameter and connected to a high-voltage (20 kV) pulsed power supply. The arc and the Helmholtz coils were powered from two independent 50-Hz generators. Current and voltage were measured at different locations of the electrical circuit. Four shunts were installed to measure the injected current $I_{BT}$, the output current $I_{arc}$, the leakage current $I_{leak}$, and the current in the Helmholtz coils $I_{coils}$. The arc voltage $U_{arc}$ was obtained by measuring the potential difference between upstream and downstream of the chamber using two voltage dividers. Measured data were recorded on an acquisition bay with a sample frequency of 1 MHz. The electric arc was filmed with a high-speed camera Photron SA5 with an exposure time of 369 ns and a frame rate of 15 000 or 20 000 frames/s.

Fig. 2 shows the radial profiles of the AMF intensity and the time delay between $B_{AMF}$ and $I_{coils}$ measured at middistance between the two contacts (spaced 25 mm apart) using a Hall probe placed on a mobile support. It can be seen that there is an important effect of the contacts upon the two parameters. The radial profile of the AMF has a saddle shape with values in 9.6–17.1 mT/kA range inside the contact gap region, while the time delay between the AMF intensity and the coil current has a bell-shaped profile with values in 3.4–5.2 ms range inside the contact gap region.

As shown in Fig. 3, the arc was triggered when the voltage between the contacts reached a peak value and interrupted after a half-wave of current. The current injection in the Helmholtz coils was triggered to 3.4 ms before the arc ignition in order to synchronize the peak of arc current with the AMF peak at the edge of the cathode. Moreover, the current half-wave in the coil had a duration of 14 ms to maintain an intense AMF between the contacts during most of the arc lifetime. The coil current was finally interrupted using an auxiliary circuit breaker.

B. Operating Parameters

The parameters used for the tests are presented in Table I. Exp. 1–7 were performed with a gap of 20 mm and arc peak
TABLE I

<table>
<thead>
<tr>
<th>Exp.</th>
<th>Larc (mm)</th>
<th>Iarc (kA)</th>
<th>Tarc (ms)</th>
<th>BAMF (mT)</th>
<th>BAMF/Iarc (mT/kA)</th>
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<td>20</td>
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<td>6.2</td>
<td>143</td>
<td>29.2</td>
</tr>
<tr>
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<td>20</td>
<td>17.2</td>
<td>13.7</td>
<td>143</td>
<td>83</td>
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<td>20</td>
<td>25.7</td>
<td>11.8</td>
<td>143</td>
<td>5.6</td>
</tr>
<tr>
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<td>20</td>
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<tr>
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<td>20</td>
<td>31.1</td>
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<tr>
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<td>143</td>
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<tr>
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<td>24.9</td>
<td>10.9</td>
<td>141</td>
<td>5.7</td>
</tr>
</tbody>
</table>

Fig. 4. (a) Example of the cathode image. (b) Same image with CSs detected using the numerical treatment.

The current values varying between 4.9 and 43.3 kA. Exp. 8–11 were performed with a gap of 30 mm and arc peak current values varying between 8.9 and 24.9 kA. All experiments were performed with a gap of about 143 mT oriented toward the cathode, except Exp. 7 during which the AMF was oriented toward the anode and its intensity was fixed at 269 mT. Note that Exp. 1–6 and 8–11 were realized one after the other with the same contacts, whereas a new pair of similar contacts was used during Exp. 7.

C. Image Processing Method

The image processing method employed to detect the CSs on the cathode image is inspired by the work of Afanas’ev et al. [11].

The first step of the method consists in the detection, selection, and density computing of isocontours of light intensity on the image of the cathode front surface. The contours are selected according to their intensity, to eliminate the darkest contours, as well as according to their size, to reject too long and too short contours which cannot surround a single spot. Next, we calculate the centroid position of each selected contour and, then, the number of isocontour centroid on each pixel. Above a certain threshold of isocontour number, a pixel is marked and considered as a spot location. A limitation of this approach is that the same spot may end up to be detected on several adjacent pixels. To solve such a situation, only the centroid of each connected pixel region is conserved. Finally, the few false spots associated with a local minimum of light intensity, which may be detected after the complete processing procedure, are excluded based on the additional threshold filtering. The result of these successive operations is shown in Fig. 4.

CS coordinates need then to be corrected to take into account the deformation of the cathode surface caused by the tilting of the camera. This can be done using a projective transformation relating the spot coordinates on the deformed image \((x, y)\) to the spot coordinates on the rectified image \((x', y')\) [15]

\[
\begin{align*}
    x' &= \frac{h_{11}x + h_{12}y + h_{13}}{h_{31}x + h_{32}y + 1} \\
    y' &= \frac{h_{21}x + h_{22}y + h_{23}}{h_{31}x + h_{32}y + 1}.
\end{align*}
\]

The transformation involves eight coefficients \(h_{i,j}\). Those coefficients were determined from four reference points taken from a 10-mm-square reticle grid which was disposed after the tests on the front surface of the cathode and shot with the same viewing angle as the one used during the experiments.

The projective transformation is also applied to the points defining the contour of the cathode surface. Due to experimental uncertainties, the cathode contour obtained after this step is still elliptic with an eccentricity below 0.4. Thus, a final correction step is needed to make the contour perfectly circular. The radial coordinate of the points located on the cathode contour, measured from the center of the ellipse obtained after the projective transformation, is replaced by the minor radius of the ellipse. Similarly, the radial coordinate \(r_{spot}\) of a CS, defined with respect to the center of the ellipse obtained after the projective transformation, is replaced by the following expression \(r_{spot}(1 - \epsilon^2 \cos^2 \phi_{spot})^{1/2}\) where \(\epsilon\) is the eccentricity of the ellipse and \(\phi_{spot}\) is the spot angular position with respect to the major axis of the ellipse emanating from the center of the ellipse.

From the CS map, the distribution of the current density at the cathode was reconstructed by partitioning the cathode surface into Voronoi cells, each cell enclosing a single spot. The current density in each cell was considered to be inversely proportional to the cell area. Next, an azimuthally averaged radial profile of the cathode current density was determined. This profile was calculated using a harmonic mean formula (instead of an arithmetic mean) in order to be less sensitive to extreme values, which may occur when several CSs are located very close to each other, leading to very small Voronoi cells.

III. ARC COLUMN

In this section, we first describe the evolution of the arc appearance during the current wave for two different peak values with a gap of 20 mm. Then, we detail the various arc modes observed for the range of conditions investigated in this paper.

Fig. 5 presents an example of the currents and arc voltage as a function of time measured during Exp. 3 and 6 that were carried out with the same gap length of 20 mm and a peak current of 25.7 and 36.3 kA, respectively. The AMF intensity and the overall plasma luminosity, defined as the integration of light intensity in the contact gap region, are also presented in Fig. 5. For both cases, a leakage current (up to 3 kA) that matches with the difference between \(I_{arc}\)
and $I_{BT}$ exists during most of the first half-wave of the arc current, meaning that a fraction of CSs is located on the walls of the chamber, while no significant leakage current is detected during the second half-wave of the arc current. As will be seen in the following, the existence of a significant leakage current during the first half-wave of current is due (partly if not completely) to the location of spots on the lateral surface of the cathode immediately after arc ignition. Those spots may cause significant leaks of plasma out of the interelectrode space, which may enhance the apparition of the CSs on the walls of the chamber. In contrast, during the second half-wave of current, most of the CSs are located on the front surface of the cathode, reducing the current leaks. A very high spike of the arc voltage is observed at the instant of ignition of the arc. Afterward, the variations of $U_{arc}$ are heavily influenced by the impedance of the experimental circuit.

Fig. 6 shows the images of the arc column every millisecond during Exp. 3 and 6. As seen in Fig. 6(a), after arc ignition, the CSs are localized on the edge of the cathode, covering only a fraction of the circumference. From 1 to 6 ms, the spots spread from the edge to the center of the cathode covering almost completely the cathode surface at the peak current. Individual plasma jets produced by the spots are clearly visible in the near cathode region. As the current increases, the plasma jets mix progressively and form a relatively homogeneous interelectrode plasma, which is the characteristic of an arc operating in a diffuse mode. From 7 to 11 ms, during the current decrease phase, the luminosity of the interelectrode plasma decreases gradually. As seen in Fig. 5(a), the overall luminosity of the plasma is roughly proportional to the arc current. As shown in Fig. 6(b), the evolution of the arc appearance at higher current is significantly different. Until 4 ms, the arc develops similarly to that observed in Fig. 6(a). However, contrary to Fig. 6(a), from 5 to 8 ms, the plasma distribution is strongly nonuniform. A very bright plasma axial column emerges and grows from the central part of the contacts, surrounded by a diffuse plasma column. This corresponds to the so-called diffuse columnar mode. The presence of this bright column is responsible for a strong increase of the overall luminosity of the plasma, as observed in Fig. 5(b). At 9 ms, the arc appears diffuse again. Then, the plasma becomes darker with the decrease of the arc current. While the central column luminosity decreases, the column radius changes only a little. Note that contrary to Fig. 6(a), the CSs occupy completely the cathode surface at the current peak value. After the arc extinction, the optical inspection of the contacts revealed no
traces of melting on the anode surface, which indicates that the anode remained passive during arcing.

Figs. 7 and 8 show the arc appearance at the peak of current for all the performed experiments. Fig. 7 refers to a gap of 20 mm, while Fig. 8 refers to a gap of 30 mm.

When the gap is positioned at 20 mm, essentially three different arc modes can be observed. For currents lower than 4.9 kA [see Fig. 7(a)], the arc operates in a multiple arc mode. In this mode, the plasma jets emitted by the CSs do not overlap. At currents higher than 17.2 kA [see Fig. 7(b)–(e)], the arc becomes diffuse. The mixing of the plasma jets produces a quite uniform plasma. Moreover, with the increasing current, the mixing of the plasma jets tends to take place closer to the cathode. Finally, for current higher than 36.3 kA [see Fig. 7(f)], the arc appears as a diffuse columnar arc with the formation of a bright plasma column in the central part of the contacts. Note that, while the arc current in Exp. 7 [see Fig. 7(g)] was higher compared with that in Exp. 6 [see Fig. 7(f)], the arc remains diffuse in Exp. 7 because the applied AMF is stronger. In Fig. 7(b)–(e), a counterclockwise inclination of the plasma jets is clearly visible. The inclination becomes more pronounced when the current increases. As discussed by Jia et al. [16], the flow direction of the jets is dependent on that of the composite magnetic field resulting from the superposition of the AMF and the azimuthal selfgenerated magnetic field. The inclination of this composite magnetic field gets stronger when the current increases, giving a more pronounced inclination of the jets. In accordance with this explanation, it is observed that the plasma jet inclination becomes clockwise in Exp. 7 [see Fig. 7(g)] due to the reversal of the AMF direction.

When the gap is positioned at 30 mm, only two arc modes are observed. The multiple arc mode is observed again at low current [see Fig. 8(a)], while the arc is diffuse at currents higher than 13 kA [see Fig. 8(b)–(d)]. In contrast to the experiments with a 20-mm gap, the arc exhibits no diffuse columnar mode. This may be related to lower values of the arc current investigated for a 30-mm gap (24.9 kA instead of 36.3 kA under a similar AMF intensity). The lowest value reached by the ratio $\frac{B_{AMF}}{I_{arc}}$ for a 30-mm gap is $5.7 \text{ mT/kA}$. This value remains larger than the one for Exp. 6 with a 20-mm gap, during which a diffuse columnar arc mode was observed. Note that besides the influence of the ratio $\frac{B_{AMF}}{I_{arc}}$, we cannot exclude the effects related to the increase of the gap length on the arc operating mode. As it was observed for a 20-mm gap, the plasma jets exhibit again a counterclockwise inclination which gets stronger with the rise of the current.

Fig. 9 shows the evolution of the arc mode observed during Exp. 5–7 as a function of the instantaneous current and the AMF magnitude. As the identification of the transition between the multiple arc mode and the diffuse arc mode is not straightforward (and based on visual criterion), the boundary between these two modes is not represented in Fig. 9. This figure suggests a linear relationship between the critical current and the critical AMF magnitude separating the existence domain of the diffuse mode and the diffuse columnar mode

$$I_{arc} = 0.1[kA \cdot mT^{-1}]B_{AMF} + 17[kA].$$

This criterion is close to that deduced from the diagram presented by Schade and Shmelev (see [17, Fig. 1]) given for 55-mm-diameter copper contacts spaced 10 mm apart. It is also interesting to note that the curves relative to Exp. 5 and 7 remain below the derived boundary between the diffuse and diffuse columnar modes, in accordance with the observations made on the arc images.
IV. Cathode Spots

In this section, the evolution of the spatial distributions of the CSs and the current density is studied on the cathode images posttreated with the previously presented CS detection method. Afterward, an estimation of the average current carried by a single spot is also presented.

A. Cathode Spot Distribution

First, the initial propagation of the CSs after the arc ignition is described. As shown in Fig. 10 for the case of Exp. 3, because of the lateral trigger system, the first CSs appear on the lateral surface of the cathode. These spots exhibit a very fast anticlockwise rotation motion around the cathode under the influence of the AMF \[9\]. From about 100 \(\mu s\), some CSs reach the front surface, emerging at various locations along the circumference of the cathode. These spots are much slower than the spots established on the lateral surface. They begin to effectively spread over the cathode surface from about 700 \(\mu s\). Finally, the CSs established on the lateral surface of the cathode disappear totally at around 1 ms for that particular experiment.

Fig. 11 presents the typical time evolutions of the CS distribution which were observed depending on the arc peak current. Fig. 11(a) shows that at low arc current (up to 13 kA for the present conditions, i.e., in Exp. 1, 8, and 9), the CSs form a compact group (with no enclosed empty region) that occupies only a reduced fraction of the cathode surface. At high current (above 36 kA for the present conditions, i.e., in Exp. 6 and 7), as shown in Fig. 11(d), the CSs appear first along the large sections of the circumference of the cathode, before spreading across the entire cathode surface. At the current peak, the whole cathode surface is occupied by the CSs. After the current peak, the CSs tend to align along spiral arms originating from the center of the cathode. For intermediate values of current (from 17.2 to 31.1 kA for the present conditions, i.e., in Exp. 2–5, 10, and 11), the CS distribution exhibits two different behaviors. Similar to the case at high current, a CS empty region within the spatial distribution of the CSs is formed during the rise of current as a result of the expansion of the CSs from the edge toward the center of the contact. The empty region may either be eventually totally filled and disappear as in Fig. 11(b) or persist, although its size decreases while the current rises, until the end of arcing as in Fig. 11(c). As seen in Fig. 11 and confirmed by the observations made in the other experiments of Table I, it seems that the evolution of the CS empty region depends on its location with respect to the axis of symmetry of the cathode. The empty region eventually disappears in the case of an off-centered location, whereas it remains always present when its location is relatively centered.

Note that in all cases, during the decrease of the arc current, the disappearance of the CSs seems to happen homogeneously over the cathode surface. Our results do not reveal any noticeable effect of the gap length on the CS distribution. Moreover, the presence of a bright plasma column at the center of the contacts in Exp. 6 seems to have no influence on the CS distribution.

B. Cathode Spot Average Current

Fig. 12 shows an estimation of the average current carried by a CS, which was computed by dividing the instantaneous total arc current by the number of spots detected at that instant. The quite high values of the spot current during the first milliseconds in some experiments can be explained by the presence of an important proportion of spots on the lateral surface of the cathode. Our processing method discards those spots. The number of spots is underestimated, and the spot current is hence overestimated. Similarly, the number of spots may be slightly underestimated (hence the spot current will be slightly overestimated) during most of the arc lifetime because of the ejection of spots out of the front surface of the cathode as a result of repulsive forces between the spots.
because of the initial repartition of the CSs on the edge of the cathode, the current density exhibits a peak at the cathode edge during the first milliseconds. Next, as the current increases and spots expand on the cathode surface, the peak widens and the front of the current density moves toward the center of the cathode. It is interesting to note that the current density at the edge of the cathode shows only slight variation during the propagation of the front. At the current peak, when the CSs occupy completely the cathode surface, such as in Exp. 4 and 6, the current density is approximately evenly distributed. In contrast, in Exp. 5, because of the persistence of a central CS empty region, the current density at the current peak is nonuniform with minimum values reached naturally near the center of the cathode. For all experiments, after the current peak, the current density tends to decrease uniformly over the surface. Note that the very large values of the current density observed close to the cathode center at 7 and 9 ms in Exp. 6 are believed to be computation artifacts, induced by a small number of spots averaged close to the center.

D. Discussion

CS motion (which is a random walk when no magnetic field is present) is strongly influenced by a magnetic field. In the presence of a tangential magnetic field, it is well known that a CS is subjected to a directional “retrograde” motion, which is in the direction opposite to that given by the Lorentz force \( \mathbf{J} \times \mathbf{B} \). The velocity of this directional motion depends on the material of the cathode and the magnetic field magnitude [16]. Superposing an AMF to the tangential magnetic field causes an additional angular drift with respect to the retrograde direction (called the Robson drift) [19]. The deflection angle \( \theta \) was found to be proportional to the angle formed by the total magnetic field with the cathode surface [16]

\[
\theta = \eta \tan \left( \frac{B_{\text{AMF}}}{B_t} \right) \tag{3}
\]

where the coefficient \( \eta \) depends, among others, on the cathode material. In a high current VA, as many CSs are present simultaneously on the cathode surface, the retrograde motion of the CSs under the combined effect of the selfmagnetic fields generated by every spot results in selfrepulsion between the CSs and the expansion of the CSs over the cathode surface [16].

The analysis of the CS distributions in Section IV-A showed that the presence of an empty region within the CS distribution until the end of arcing, leading to only a partial occupation of the cathode surface, seems to correlate with the relatively centered location of the empty region, this characteristic being itself linked to the initial repartition of the CSs along the cathode circumference. In the following, an interpretation of this result by examining the direction of the retrograde motion of the whole CSs is proposed. The direction of the retrograde motion of the CSs was calculated from the CS map presented previously, following a similar approach to that employed by Jia et al. [20]. The tangential magnetic field produced by the current of a spot \( i \) at the location of a spot \( n \) is given by

\[
\mathbf{B}_i(n) = \frac{\mu_0}{2\pi} \frac{(\mathbf{I}_{\text{spot}} \mathbf{e}_z) \times \hat{r}_{i-n}}{\| \hat{r}_{i-n} \|^2} \tag{4}
\]
where $\vec{r}_{i-n}$ is the displacement vector from the location of spot $i$ to the location of spot $n$. Then, the direction of the retrograde motion of spot $n$ is given by
\[
- \left( \frac{I_{\text{spot}}}{\pi R^2_{\text{spot}}} \right) \times \sum_{i=1}^{N_{\text{spot}}} \vec{B}_i(n) = \frac{\mu_0 I_{\text{spot}}^2}{2\pi^2 R^2_{\text{spot}}} \sum_{i=1}^{N_{\text{spot}}} \frac{\vec{r}_{i-n}}{||\vec{r}_{i-n}||^2}.
\]

(5)

Due to the presence of an AMF, one needs also to take into account the angular deflection with respect to that direction caused by the AMF, the deflection angle being determined from (3). Based on the AMF magnitude profile presented in Fig. 2 and considering a spot current of 36.5 A, a spot radius of 50 $\mu$m [21], and a typical value of the parameter $\eta$ that equals to 0.8 (similar to that given for CuCr30 contacts in [22]), the direction of the retrograde motion of every CS can thus be calculated from the CS location map using (5). Fig. 14 shows an example of calculation results at three particular time instants.

When the CS empty region is off-centered as in Exp. 4, it is observed that part of the CSs (essentially those close to the center of the cathode) have a motion directed toward the inside of the empty region and contribute to the decrease of the size of the empty region. Between 4 and 5 ms, the area of the empty region falls by half. At 6 ms, the empty region disappears and the cathode is fully occupied by the CSs.

In contrast, when the CS empty region is relatively well centered as in Exp. 5, a very few CSs exhibit a motion directed toward the inside of the empty region. Therefore, the empty region, although decreasing in size, remains present until the end of arcing. At 6 ms, it represents about 10% of the cathode surface. Thus, the correlation observed between the persistence of the empty region inside the CS distribution and the centered position of the empty region in the case of moderate arc current may be explained by the CS motion direction, which does not favor the filling of the empty region.

V. Conclusion

The VAs between CuCr25 static contacts spaced 20 and 30 mm apart with a range of peak current between 3.9 and 43.3 kA and under a peak value of the AMF of 143 or 269 mT were studied with a high-speed camera to characterize the arc appearance and the CS distribution.

For a 20-mm gap, three arc modes were successively observed with increasing arc current, respectively, a multiple arc mode, a diffuse arc mode, and a diffuse columnar arc mode. The diffuse columnar arc mode occurred for a value of the $B_{\text{AMP}}/I_{\text{arc}}$ ratio of around 4 mT/kA. For a 30-mm gap, the maximum current investigated was smaller (yielding to a minimum value of the $B_{\text{AMP}}/I_{\text{arc}}$ ratio of around 6 mT/kA). No diffuse columnar arc mode was observed; the arc exhibits either a multiple arc mode or a diffuse mode.

Various types of the CS distribution have been identified, which are to some extent dependent on the specific arc ignition procedure on the lateral surface of the cathode used in this paper. At low currents, after reaching the front surface of the cathode, the CSs form a distribution without the empty region, which covers only a fraction of the cathode surface. At moderate currents, a closed region unoccupied by the CSs forms within the CS distribution during the development of the arc. This empty region, although decreasing in size, remains present until the end of arcing, when its location is centered with respect to the cathode axis. In contrast, the empty region was found to be eventually totally filled by the CSs when its location is off-centered. An explanation of this behavior was proposed in terms of the direction of the retrograde motion of the CSs located at the periphery of the empty region. When the current is further increased, due presumably to the increase of the CS density, the cathode surface is always fully occupied by the CSs at the current peak. No significant modification of the CS distribution with the gap length was observed. An average spot current of 36.5 ± 2.5 A was estimated. Our results suggest that the current density is relatively uniform in the regions occupied by the CSs.

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